



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	
Shunpei YAMAZAKI et al.	)	Examiner: Gene M. Munson
Serial No. 09/578,895	)	Group Art Unit: 2811
Filed: May 26, 2000	)	
For: ELECTRO-OPTICAL DEVICE AND ELECTRONIC	)	
DEVICE	)	

**INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

WO-1998/036405; EP 942407; JP 11-097705; US 6255705; US 5904514; Choi et al. article; JP 10-189998; EP 1052701 were cited in a counterpart European patent application mailed September 19, 2005.

US 6529178; US 2003/0071771; WO-1998/036405; and EP 942407 are in the same family. US 5503731 is in the same family as US 5904514. US 2005/0156174 is in the same family as EP 1052701.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initial a copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

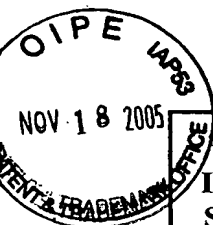
Respectfully submitted,

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(use as many sheets as necessary)</i>				<b>Complete if Known</b>	
				Application Number	09/578,895
				Filing Date	May 26, 2000
				First Named Inventor	Shunpei YAMAZAKI et al.
				Art Unit	2811
Examiner Name	Gene M. Munson				
Sheet	1	of	1	Attorney Docket Number	740756-2160

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code <sup>2</sup> (if known)			
		US-5,503,731	04/02/1996	KONUMA et al.	
		US-5,904,514	05/18/1999	KONUMA et al.	
		US-6,255,705 B1	07/03/2001	ZHANG et al.	
		US-6,529,178 B1	03/04/2003	KIMURA	
		US-6,940,214 B1	09/06/2005	KOMIYA et al.	
		US-2003/0071771 A1	04/17/2003	KIMURA	
		US-2005/0156174 A1	07/21/2005	MURAKAMI et al.	
		US-			
		US-			
		US-			
		US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)				
		EP-0942407 A1	09/15/1999	KIMURA		FULL
		EP-1052701 A2	11/15/2000	MURAKAMI et al.		FULL
		JP10-189998	07/21/1998	HAYASHI		AB
		JP11-097705	04/09/1999	ISHII		AB
		WO-1998/036405	08/20/1998	KIMURA et al.		AB

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		CHOI, K. et al., "Gate-Overlapped Lightly Doped Drain Poly-Si Thin-Film Transistors for Large Area-AMLCD", IEEE Transactions on Electron Devices, June 1998, Vol. 45, No. 6, pp. 1272-1279.	
		European Search Report (Application No. 00112035.1 – 2203 PCT; EP 4211), dated: September 19, 2005.	

Examiner Signature	Date Considered
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.